

<b>Notice of References Cited</b>	Application/Control No. 10/811,490		Applicant(s)/Patent Under Reexamination CHO ET AL.	
	Examiner William C. Dowling		Art Unit 2851	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	D	US-6,619,802	09-2003	Janssen et al.	353/31
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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